EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	(wafer and temperature and plate$2 and (proximity adj pin$2) and enclosure).clm.	US-PGPUB	OR	ON	2006/07/19 17:49
L2	3	((wafer substrate) and temperature and element$2 and pin$2 and (oven furnace)).clm.	US-PGPUB	OR	ON	2006/07/19 17:53
L3	3	((wafer substrate) and (heat$3 cool$3 hot cold) and (plater$2 element$2) and pin$2 and (oven furnace)).clm.	US-PGPUB	OR	ON	2006/07/19 17:54
L4	55	((wafer substrate) and (heat$3 cool$3 hot cold) and (plater$2 element$2) and pin$2 and enclosure).clm.	US-PGPUB	OR	ON	2006/07/19 17:54
L5	60	((wafer substrate) and (heat$3 cool$3 hot cold) and (plate$2 element$2) and.pin$2 and enclosure).clm.	US-PGPUB	OR	ON	2006/07/19 17:59
L6	145	((wafer substrate) and (heat$3 cool$3 hot cold) and (plate$2 element$2) and pin$2 and (oven furnace chamber)).clm.	US-PGPUB	OR	ON	2006/07/19 17:59
L7	137	6 not 5	US-PGPUB	OR	ON	2006/07/19 17:59